

Notice of References Cited	Application/Control No. 10/707,356	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Paul D. Kim	Art Unit 3729	Page 1 of 1

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*	B	US-6,441,560	08-2002	Hunter, Iain M.	315/169.1
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.